

10/551194

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Appl. No. : National Phase of PCT/JP2004/003440
Applicant : KOICHI et al
Filed : September 29, 2005
TC/A.U. :
Examiner :

Docket No. : 2946-195
Customer No. : 6449
Confirmation No. :

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with applicants duty of disclosure under 37 C.F.R. 1.56, enclosed is a copy of the International Search Report in the corresponding international application. The relevance of the references is noted in the International Search Report. We understand that the references have been forwarded by the International Bureau, and are available to the Examiner, but if the Examiner needs copies of any of the references, the Examiner is requested to advise counsel accordingly.

In the event that any fees are due with this paper, please charge our Deposit Account No. 02-2135.

Respectfully submitted,

By


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RBM/cb
Enclosures

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Complete if Known	
				Application Number	New 10/551194
				Filing Date	September 29, 2005
				First Named Inventor	Terai KOICHI et al
				Group Art Unit	
				Examiner Name	
				Confirmation No.	
Sheet	1	of	1	Attorney Docket Number	2946-195

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office ³ Code	Number ⁴	Kind ⁵ (if known)			
	1.	JP	2631946	B2	Shima Seiki Mfg., Ltd.	7/16/97	
	2.	JP	5-78960	A	Asahi Chemical Industry Co., Ltd.	3/30/93	
	3.	JP	2913266	B2	Shima Seika Mfg., Ltd.	6/28/99	
	4.	WO	01/64987	A1	Shima Seiki Mfg., Ltd.	9/7/01	
	5.	JP	11-25281	A	Kabushiki Kaisha Seren System Service	1/29/99	
Examiner Signature					Date Considered		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.